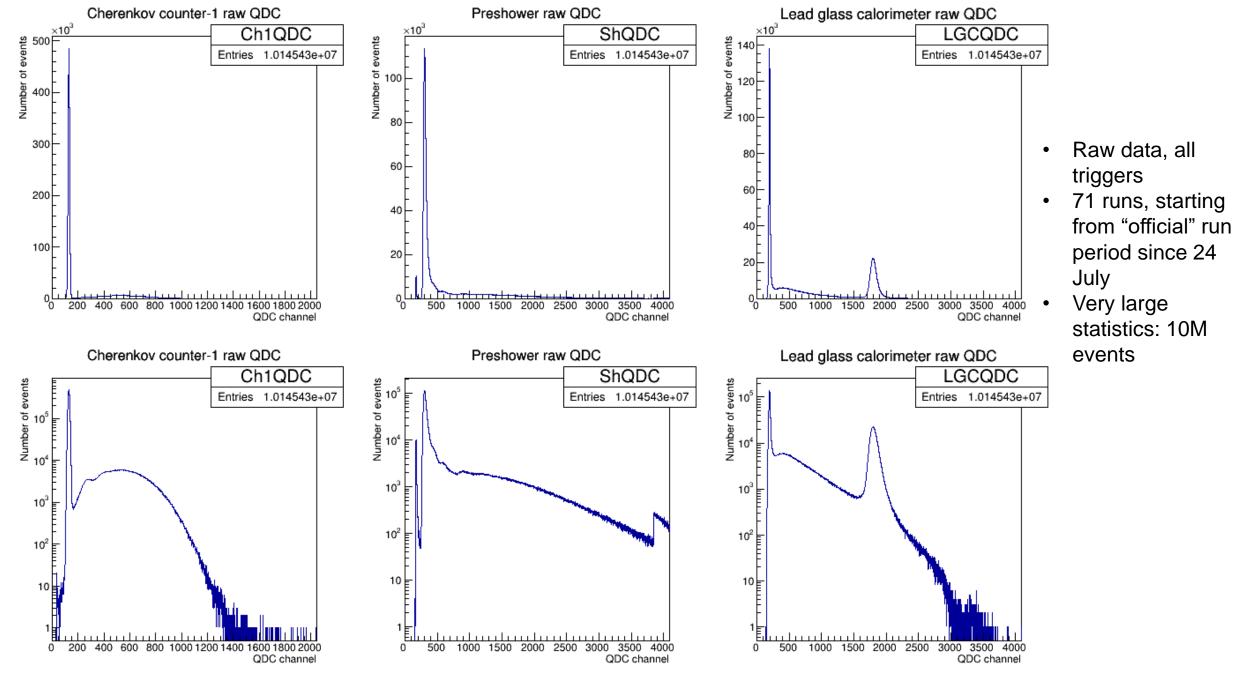
Test beam 2024: purity of beam particle samples

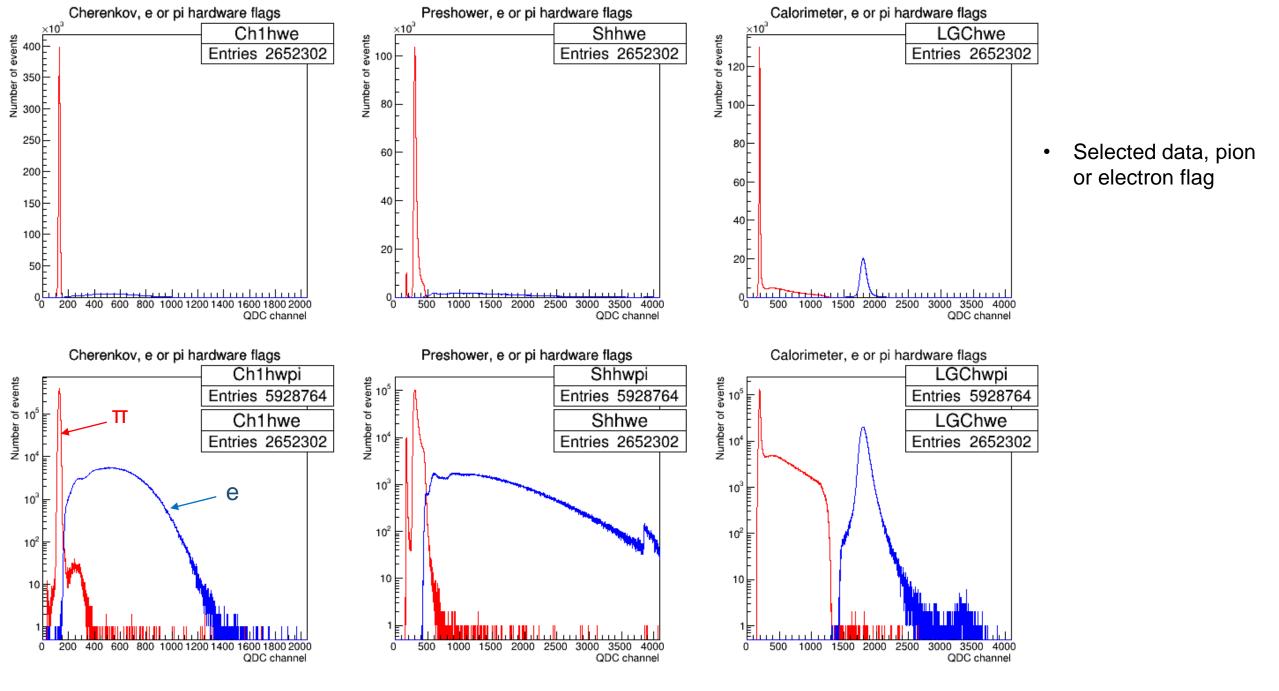
V.O.Tikhomirov^{1,2}

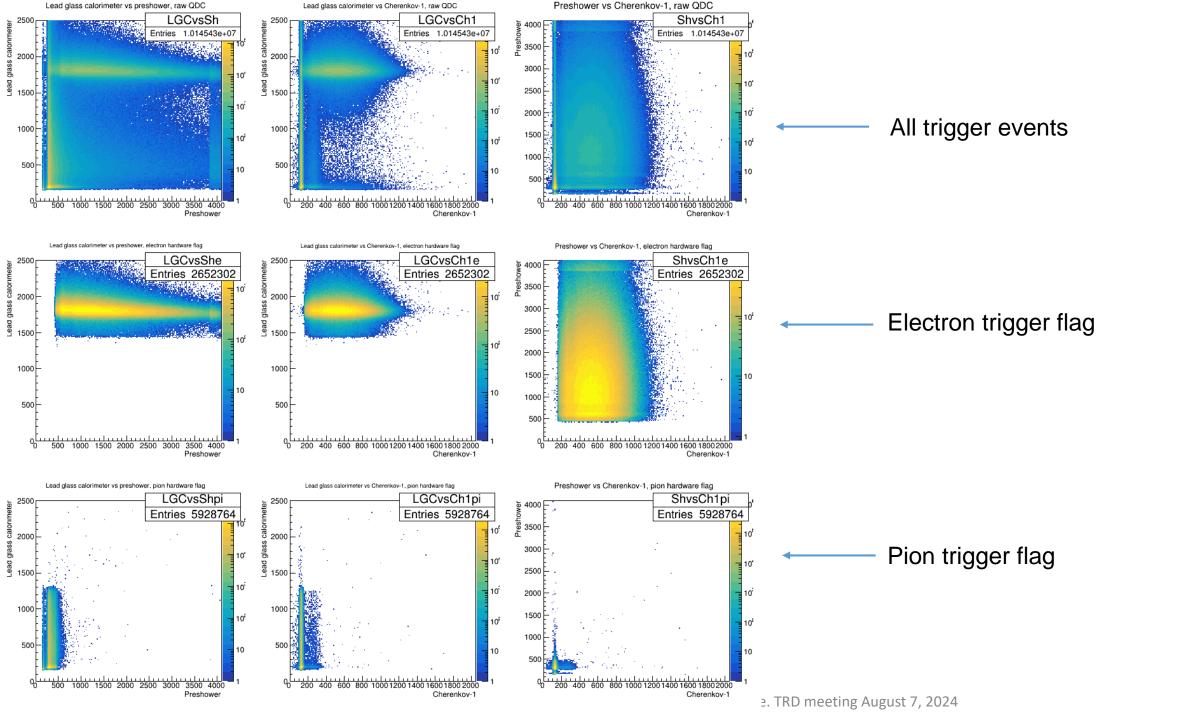
¹National Research Nuclear University "MEPhI" ²P.N.Lebedev Physical Institute of the Russian Academy of Sciences

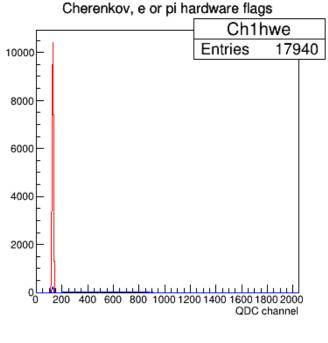
TRD meeting, 07.08.2024

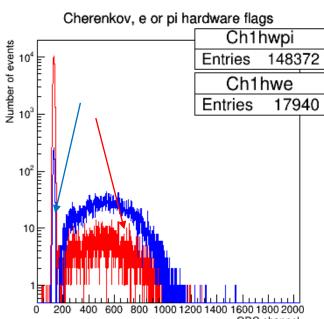


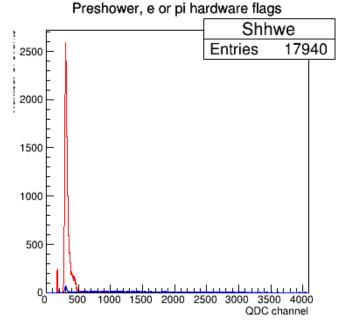
V.Tikhomirov. Test beam 2024: purity of beam particle sample. TRD meeting August 7, 2024

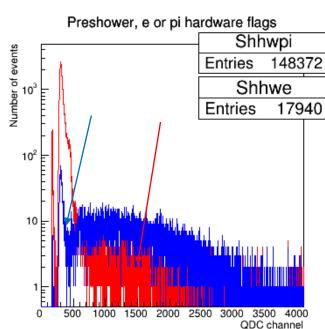


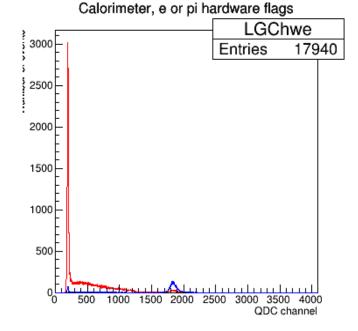


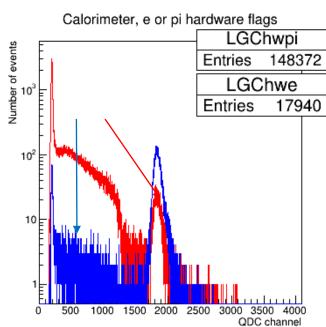










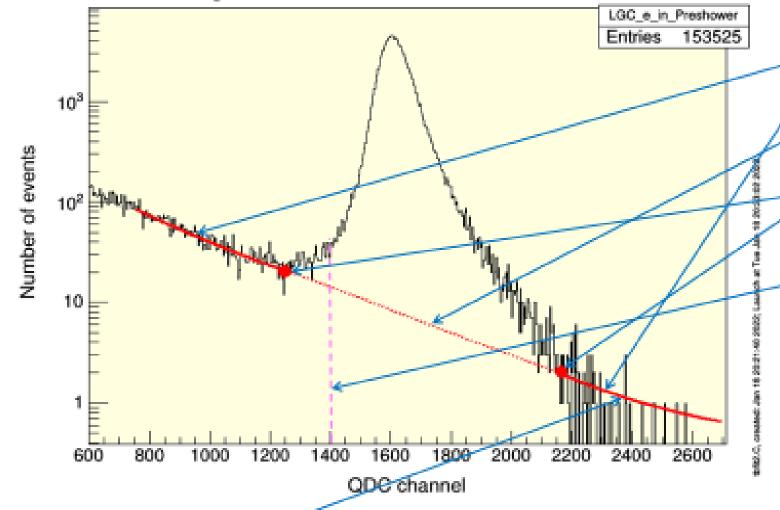


- Run # 397/1100: Accepted as "good", but really is not: for unknown reason particle identification flag is wrong for many events.
- (Spent a lot of time identifying this bad run in the list)
- Fortunately, there is one more run #435 with the same conditions (distance, radiator, angle)

- Next steps: estimate the purity of beam particle samples, selected by our supporting detectors: multiplicity counter, preshower, lead glass calorimeter, Cherenkov detector.
- Next slides reminder of the procedure used in 2021 test beam analysis.
- Some other new approaches are also possible for these estimations.

Electron sample purity: test beam 2021

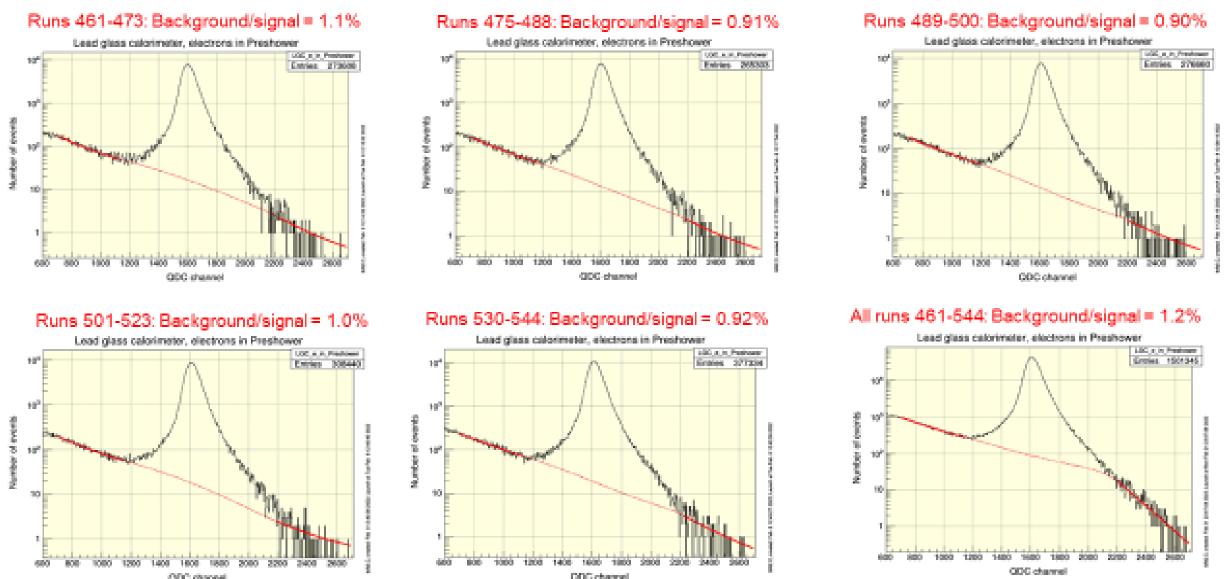
Lead glass calorimeter, electrons in Preshower



- Fit procedure:
- Fit separately left and right side of background.
- Sew left and right branches by threedegree polynomial. Polynomial coefficients are determined from the condition of continuity and smoothness at the joining points.
- Count the number of background events N_{bgm} as integral of fitting function in the range above our threshold for electrons in LGC. Count total number of events N_{total} in histogram above this threshold. Define number of signal (i.e. produced by electron) events N_{signal} as N_{total} N_{bgm}. Define pion contamination as N_{bgm}/N_{signal}.

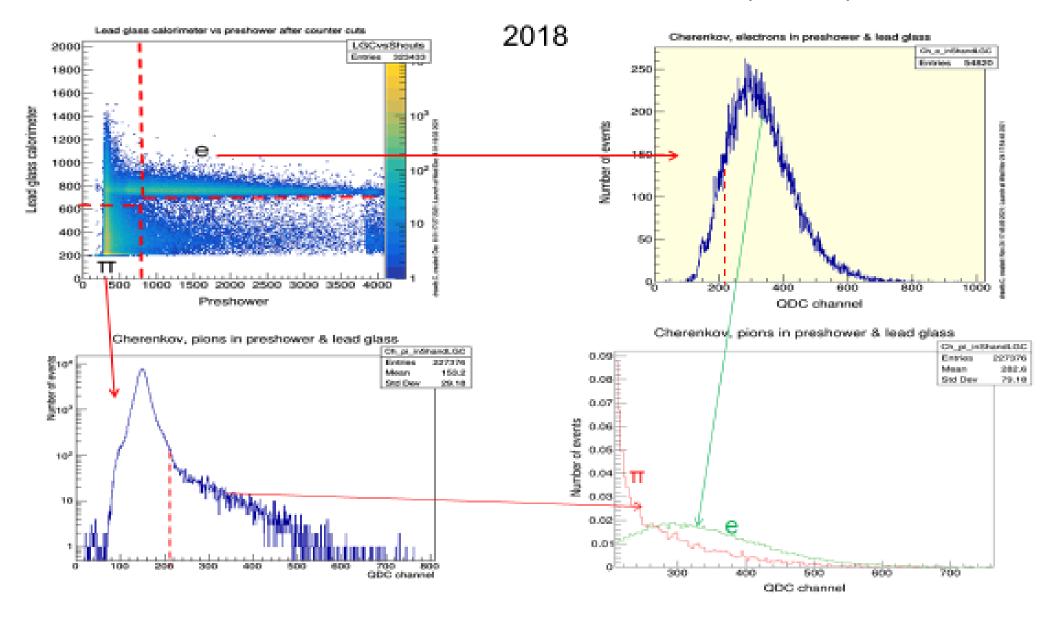
- In 2021 test beam measurements we had a run (#450) with very large statistics. So it is possible to fit directly the distribution (particularly the right branch) of electrons in calorimeter after selection by preshower. Here background/signal ratio is 1.1%
- Results are depend on interval choice for background fitting and range from 1.0% to 1.3%.

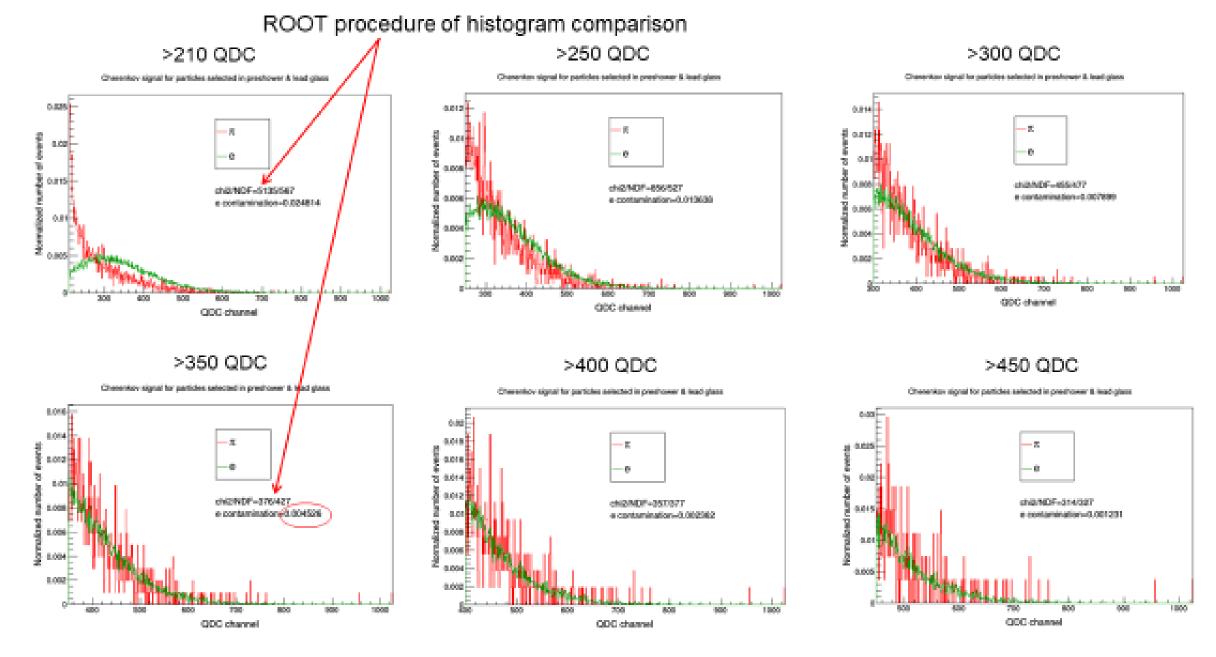
Electron sample purity: test beam 2021



Conclusion: pion background in selected electrons is ~1%

Estimation of electron contamination in selected pion samples





V.Tikhomirov. Beam composition and purity. TRD meeting, March 30, 2022.